



Receipt  
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S/N: 09/718,319

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yuen, et al.	Group Art Unit: 1765
Serial No: 09/718,319	<b>Attention:</b> Office of Initial Patent Examination Customer Service Center
Confirmation No: 3056	Atty Docket No. 004704 USA/ETCH/SILICON/JB1
Filed: 11/21/2000	May 17, 2001
For: Etching a Substrate in a Process Zone	San Francisco, California

CORRECTION TO FILING RECEIPT

Office of Initial Patent Examination  
Customer Service Center  
Commissioner for Patents  
Washington, D.C. 20231

Sir/Madam:

Applicant respectfully requests the Patent Office to correct the Filing Receipt and forward a corrected copy to Applicant.

Please note the change highlighted on the enclosed copy of the Filing Receipt. Specifically, the correction is as follows:

1. Filing Date should read:

11/21/2000

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:

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Dated May 17, 2001

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TC 1700

S/N: 09/718,319

If the Examiner should have any questions regarding the above correction, the Examiner is requested to telephone the Applicant's representative at the number listed below.

Respectfully submitted,

JANAH & ASSOCIATES  
A PROFESSIONAL CORPORATION

Date: 5/17/01

By: Ashok Janah  
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Encl.



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
 UNITED STATES PATENT AND TRADEMARK OFFICE  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE RECD	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/718,319	11/22/2000	1765	1722	4704/USA/ETCH/SILICON	6	54	8

11/21/2000

CONFIRMATION NO. 3056

## FILING RECEIPT



\*OC00000005913357\*

APPLIED MATERIALS, INC.  
 Patent Department  
 P.O. Box 450A  
 Santa Clara, CA 95052

Date Mailed: 03/28/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the request for corrections (if appropriate).

## Applicant(s)

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 Thorsten B. Lill, Sunnyvale, CA;

## Continuing Data as Claimed by Applicant

## Foreign Applications

If Required, Foreign Filing License Granted 03/28/2001

## Projected Publication Date:

Non-Publication Request: No

Early Publication Request: No

## Title

Etching a substrate in a process zone

## Preliminary Class

RECEIVED  
 APR 2 1 2001  
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Data entry by : LUENG, YIN

Team : OIPE

Date: 03/28/2001

